

Attorney Docket No.: ASMEX.367A

Date: August 19, 2003

Page 1

REQUEST FOR CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114

Δ	nn	100	int:
$\boldsymbol{\Lambda}$	$\omega \omega$	1100	uu.

Michael A. Todd

Application Number:

10/074,534

Filing Date:

February 11, 2002

Title:

PROCESS FOR DEPOSITION OF

SEMICONDUCTOR FILMS

Examiner Name:

Shrinivas H. Rao

Group Art Unit:

2814

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Mail Stop RCE, Alexandria, VA 22313-1450, on

August 19, 2003

(Date)

Mollon

Commissioner for Patents P.O. Box 1450 Mail Stop RCE

Alexandria, VA 22313-1450

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified ion.

Submission Required under 37 C.F.R. § 1.114:

(X) Enclosed:

(X) Information Disclosure Statement (IDS)

(X) Return Postcard application.

- 1.
- 2. Fees:
 - (X) RCE fee (\$750 large entity)
- 3. Payment:
 - (X) Check in the amount of \$750 to cover the above fees.
 - (X) The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. § 1.16 and § 1.17 which may be required, now or in the future, or credit any overpayment to Deposit Account No. 11-1410.

Address all future communications to Customer No. 20,995.

Dated:

08/25/2003 ANDNDAF1 00000133 10074534

01 FC:1801

750.00 OP

Registration No. 39,287 Attorney of Record Customer No. 20,995

(619) 235-8550

S:\DOCS\JOM\JOM-5166.DOC:081903